



2007
TPW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2818
Examiner: Chuong A. Luu
Confirmation No.: 6341

In Re PATENT APPLICATION Of:

Applicant: Noriko Tomita et al.)
Serial No.: 10/660,490)
Filed: September 12, 2003)
For: SEMICONDUCTOR SUBSTRATE)
SURFACE PROTECTION METHOD)
Attny Ref.: OHG 135)

)

October 10, 2006

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This paper is filed, with an RCE, in response to the Final Official Action mailed on June 15, 2006. Payment for one month's extension of time is attached. Please charge our Deposit Account No. 18-0002 if any additional fees are needed to enter this paper, and please advise us accordingly. It is noted that no petition is required because of the authorization to charge, but this paper is a petition for extension of time. No fee for extra claims is due.

Please consider the Remarks below.

Respectfully submitted,

Nick Bromer
Nick Bromer (Reg. No. 33,478)
(717) 426-1664
RABIN & BERDO, P.C.
CUSTOMER NO. 23995
Telephone: (202) 371-8976

October 10, 2006
Date